

MAR 24 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BERMAN et al.

Attorney Docket No.: 03-0962/LSI1P232

Application No.: 10/679,004

Examiner: TOLEDO, Fernando L.

Filed: October 2, 2003

Group: 2823

Title: MECHANISM FOR IMPROVING THE
STRUCTURAL INTEGRITY OF LOW-K FILMS

Confirmation No.: 8894

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being transmitted by facsimile to fax number 703-872-9306 to the U.S. Patent and Trademark Office on March 24, 2005.

Signed:

Sue Funchess
Sue Funchess

AMENDMENT B

*Please enter
the 3/25/05*

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Examiner Toledo:

This Amendment is in response to the Final Office Action dated February 23, 2005. The Applicants thank the Examiner for his consideration of issues raised in the March 22, 2005 telephonic interview. It is respectfully requested that the above-referenced patent application be reconsidered in light of the amendments and comments included hereinbelow. Kindly amend the above-entitled application as set forth below:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.